Mark Bowden

List of Publications by Year in descending order

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15	345	9	1058476
papers	citations	h-index	g-index
15 all docs	15 docs citations	15 times ranked	245 citing authors

#	Article	IF	Citations
1	First Divertor Thomson Scattering Measurements on Mast-U., 2022,,.		0
2	Low temperature Thomson scattering on MAST-U. Review of Scientific Instruments, 2021, 92, 043545.	1.3	9
3	Optical emission from a †beam mode' transparent cathode glow discharge. Plasma Sources Science and Technology, 2021, 30, 075010.	3.1	1
4	Diagnosing asymmetric bipolar HiPIMS discharges using laser Thomson scattering. Plasma Sources Science and Technology, 2021, 30, 105019.	3.1	9
5	Influence of cathode grid geometry upon mode structure of a transparent cathode discharge. Physics of Plasmas, 2020, 27, .	1.9	8
6	Comparison of Langmuir probe and laser Thomson scattering for electron property measurements in magnetron discharges. Physics of Plasmas, 2019, 26, 073515.	1.9	15
7	Mode Structure of a Transparent Cathode Discharge. IEEE Transactions on Plasma Science, 2019, 47, 3124-3133.	1.3	5
8	Comparison of Langmuir probe and laser Thomson scattering for plasma density and electron temperature measurements in HiPIMS plasma. Physics of Plasmas, 2019, 26, .	1.9	25
9	Comparison of electron property measurements in an inductively coupled plasma made by Langmuir probe and laser Thomson scattering techniques. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 1999, 17, 493-499.	2.1	32
10	Diagnostics of low-density glow discharge plasmas using Thomson scattering. Plasma Physics and Controlled Fusion, 1998, 40, 1221-1239.	2.1	92
11	Measurements of electron temperature, electron density, and neutral density in a radioâ€frequency inductively coupled plasma. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 1996, 14, 144-151.	2.1	83
12	Measurements of sheath electric fields in a high pressure helium radio frequency discharge. Applied Physics Letters, 1995, 66, 1059-1061.	3.3	23
13	Measurements of the cathode sheath in a magnetron sputtering discharge using laser induced fluorescence. Journal of Applied Physics, 1993, 73, 3664-3667.	2.5	20
14	Study of the effect of a probe on the plasma in the source region of an electron cyclotron resonance discharge. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 1993, 11, 2893-2896.	2.1	9
15	Laser diagnostics of edge plasmas and laser diagnostics of plasmas for industrial applications (invited). Review of Scientific Instruments, 1992, 63, 4913-4919.	1.3	14